

JCS97 U.S. PTO
10/075172

02/13/02

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10075172	FILING DATE 02/13/2002	CLASS 451	SUBCLASS 56	GAU 3723	EXAMINER <i>Ojini</i>
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*APPLICANTS: Cron Brian;

ABANDONED

**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials <i>BD</i>	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO MI22-1804
TITLE : Method for conditioning surfaces of polishing pads after chemical-mechanical polishing, and apparatuses for conditioning surfaces of polishing pads		
U.S.DEP.T. OF COMM./PAT. & TM-PTO-436L(Rev. 12-84)		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
Amount Due	Date Paid		Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
			Sheets Drwg.	Figs.Drwg.
TERMINAL DISCLAIMER		Application Examiner		
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